

#537701
M4

U.S. Department of Commerce, Patent and Trademark Office		Docket No.: AM-1622-D1
		Serial No.: 09/489,356
- LIST OF RELEVANT ART CITED BY APPLICANT		Applicant: Shih et al.
(Use several sheets if necessary)		Filing Date: January 21, 2000
		Group: 1763

**U.S. PATENT DOCUMENTS**

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
JD	AA	5,089,746	02/18/92	Rosenblum et al.	315	111.81	
	AB	5,268,200	12/07/93	Steger	427	249	
	AC	5,272,417	12/21/93	Ohmi	315	111.81	
	AD	5,429,870	07/04/95	Kmetz et al.	428	368	
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS (Translation)

		Document Number	Date	Country	Class	Subclass	Yes	No
JD	AL	09 087072	03/31/97	JP			RECD	
JD	AM	58 034385	02/28/83	JP			RECD	
	AN						RECD	
	AO						RECD	
	AP						RECD	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	
AS	
AT	

Examiner

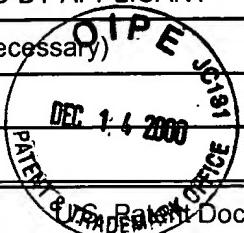
JD

Date Considered

My 10, 2001

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
		AM-1622.D1	09/489,356
LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)		Applicant	
		Hong Shih et al.	
		Filing Date	Group
		21 Jan. 2000	1763



*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>JK</i>	AA	4,716,083	12/29/87	Eichen et al.	428	457	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

Foreign Patent Documents

RECEIVED
TELETYPE CENTER
FEB 11 2001

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
<i>JK</i>	AH	1,317,617 /	5/23/73	UK				
	AJ	01-208446	8/22/89	JP			abstract	
<i>JK</i>	AK	0016252A1	10/1/80	EP				
	AL							
	AM							
	AN							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>JK</i>	AO	Partial European Search Report
	AP	
	AQ	
	AR	

Examiner

Date Considered

Hong Shih et al.

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.